

**IN THE UNITED STATES PATENT & TRADEMARK OFFICE**

Application Number : 10/527,056 Confirmation No. 6957  
Applicant : Woo-Seok CHEONG et al.  
Filed : October 20, 2005  
Tech Cntr/AU : 1792  
Examiner : Nathan K Ford  
Entitled : APPARATUS FOR MANUFACTURING  
SEMICONDUCTOR DEVICE AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR DEVICE BY  
USING THE SAME  
  
Attorney Reference : 123034-05029639  
Customer Number : 22429

**MAIL STOP AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**RESPONSE TO RESTRICTION/ELECTION REQUIREMENT**

Sir:

In response to the Restriction/Election Requirement set forth in the Office Action mailed April 29, 2008, Applicant elects Group II (claims 6-14) drawn to a method for manufacturing a semiconductor apparatus, with traverse.

Applicant respectfully traverses the restriction/election requirement. The claims of Group II (claims 6-14) drawn to a method for manufacturing a semiconductor apparatus and the claims of Group I (claims 1-5) drawn to an apparatus for manufacturing semiconductor device are closely related to each other and define a single invention. Further, Applicant respectfully submits that it would not be unduly burdensome for the Examiner to examine the claims of three groups. Applicant respectfully requests that claims **1-14** be examined.

An early Office Action on the merits is respectfully requested.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper,

including extension of time fees, to Deposit Account 07-1337 and please credit any excess fees to such deposit account.

Respectfully submitted,  
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